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**SUBCLASS**

ART UNIT  
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**EXAMINER**

## APPLICANTS

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Method for fabricating a contact pad of semiconductor device

**TITLE**

PTO-2040  
12/99[illegible]

<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>	<b>DRAWINGS</b> Sheets Drwg.      Figs. Drwg.      Print Fig.		<b>CLAIMS ALLOWED</b> Total Claims      Print Claim for O.G.	
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